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IN THE UNITED STATES DESIGNATED/ELECTED OFFICE

#4/A

International Application No. : PCT/EP2003/008805
International Filing Date : 8 August 2003 (08.08.2003)
Priority Date(s) Claimed : 04 September 2002 (04.09.2002)
Applicant(s) (DO/EO/US) : Armin KUEBELBECK ET AL.

Title: ETCHING PASTES FOR SILICON SURFACES AND LAYERS

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SIR:

Prior to calculating the national fee, and prior to examination in the National Phase of the above-identified International application, please amend as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.